

0163-0707-2X

**RESPONSE UNDER 37 C.F.R. §1.116 -  
EXPEDITED PROCEDURE EXAMINING GROUP 1722**

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

IN RE APPLICATION OF :  
Kenji MIWA et al : GROUP: 1722  
SERIAL NO: 09/158,099 :  
FILED: September 22, 1998 : EXAMINER: LIN, K.  
FOR: METHOD OF REFINEMENT OF :  
MICROSTRUCTURE OF...

**AMENDMENT UNDER 37 C.F.R. §1.116**

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Responsive to the Official Action mailed December 19, 2000, please amend the  
above-identified patent application, as follows:

**IN THE SPECIFICATION**

Please amend the specification, as follows:

Page 11, line 11, ~~delete~~ the heading "Brief Description of the Drawings" in its  
entirety.

**IN THE CLAIMS**

Please ~~cancel~~ Claims 11-14, without prejudice or disclaimer.

Please ~~add~~ new Claims 15-18, corresponding to subject matter from Claims 11-14, as  
follows:

15. (New) A method for ~~refining~~ a microstructure of a metallic material, comprising:

10B/HB  
4/25/01  
(J.E.)  
RECEIVED  
APR 19 2001  
TECHNOLOGY CENTER 1700

Sub (2)